

# PATENT APPLICATION

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q68421

Yoshinori NISHIKI, et al.

Appln. No.: 10/062,442

Group Art Unit: 1745

Confirmation No.: 2590

Examiner: John S. Maples

Filed: February 5, 2002

For:

ELECTRODE-MEMBRANE ASSEMBLY AND PROCESS FOR THE PREPARATION

**THEREOF** 

# AMENDMENT UNDER 37 C.F.R. § 1.111

# MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding Office Action of May 19, 2004, please amend the aboveidentified application as follows on the accompanying pages.

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membrane which is interposed between the two electrodes partly penetrates into the pores of the at least one porous electrode.

It is respectfully submitted that the claims as amended fully comply with 35 U.S.C. § 112, and withdrawal of the foregoing rejection is respectfully requested.

Withdrawal of all rejections and allowance of claims 1-8 is earnestly solicited.

In the event that the Examiner believes that it may be helpful to advance the prosecution of this application, the Examiner is invited to contact the undersigned at the local Washington, D.C. telephone number indicated below.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

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Date: July 28, 2004

Abraham J. Rosner Registration No. 33,276